

1974 Born in Kurashiki Japan
Lives and works in Cologne from 2016

Education

2008-2009 Studied in Germany with the support of the 2nd Shuou Fund Scholarship
1993-1999 Study of Art History and Art Education, M.A., Kobe University (J)

Solo Exhibitions

2019 LADS Gallery, Osaka (2016, 2015, 2014, 2011, 2010, 2007, 2005)
2017 „Schicht – Sicht, Farbe – Licht“, KulturBadehausBurscheid, Burscheid
2012 Yumikobo, Kurashiki
2010 Gallery K, Kurashiki (2008, 2006)
2008 JUNPUKAI Space Venere & Galeria Arietta, Okayama
Okayama Tenjinyama Bunka Plaza, Okayama
2006 Contemporary Art Space Osaka CASO, Osaka (2005, 2004)
2002 ONO Gallery 2, Tokyo (2001)

Selected Group Exhibitions

2019 "PAINTING AND CERAMIC - SHAPES BY REPETITION" with Tomomi Tanaka,
Kultur Am Kelterberg Vaihingen e.V., Stuttgart
"Now- 10 years of Shuou Fund Scholarship" , Okayama Prefectural Museum of Art,
Okayama
2018 "Tiefe Oberfläche - wie man sieht, was man sieht" mit Benjamin Rastetter, TKW,Cologne
2017 "Die Farbe Grün", Galerie Esch-Renner, Köln
"art³", ALTES PFANDHAUS, Köln
Art Fair"Contemporary Art Ruhr", Essen
2016 "Falten, Formen und die weite Welt", Galerie Esch-Renner, Cologne
"Die Farbe Rot", Galerie Esch-Renner, Cologne
2015 The 2th Soja Arts Festival "Subtleties of Beauty", Iyama-Hofukuji, Soja
2013 "the 15th Kurashiki Exhibition for Upcoming Artists", Kurashiki City Art Museum, Kurashiki
2012 "Begegnungen in Okayama", Kurashiki, Japan (part of the Okayama Prefecture Culture
Festival)
2011 "BEGEGNUNGEN - Deutschland und Japan" , TKW, Cologne
2010 "Small Paintings", Gallery Yabuki, Okayama
2007 "CROSSROAD - sympathy for art -", Kurashiki City Art Museum, Okayama
2003 "the 22nd SONPO Japan Bijyutsu zaidan Senbatu Shorei", Seiji Togo Memorial Sampo
Japan Nipponkoa Museum of Art,Tokyo

Prizes / Scholarship

2016 City of Cologne Studio Sponsorship (5 years)
2008 Awarded the 2nd Shuou Fund Scholarship
2007 Selected for TOYOTA Art Exhibition '07
2005 Selected for SHELL ART AWARD Exhibition
Excellence award at Kurashiki Gendai Art Biennale